



*CFW*  
**PATENT APPLICATION**

*RCE*  
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Yasunaga KAYAMA et al.

Group Art Unit: 2851

Application No.: 10/582,488

Examiner: M. ASFAW

Filed: June 12, 2006

Docket No.: 127629

For: PROJECTION EXPOSURE APPARATUS AND STAGE UNIT, AND EXPOSURE METHOD **MAIL STOP RCE**

**LARGE ENTITY REQUEST FOR  
CONTINUED EXAMINATION UNDER 37 C.F.R. §1.114**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. §1.114, Applicants hereby request continued examination.

☒ Applicants further request entry and consideration of the attached submission.

The above-identified application was filed on or after June 8, 1995. Thus, entry is proper under 37 C.F.R. §1.114(d).

Attached hereto is our check no. 225302 in the amount of ☒ \$810.00 as payment of the fees set forth in 37 C.F.R. §1.17(e). The Commissioner is hereby authorized to charge any additional fees or credit any overpayment associated for this filing to Deposit Account No. 15-0461.

Respectfully submitted,

*[Signature]*  
Mario A. Costantino  
Registration No. 33,565

Patrick T. Muffo  
Registration No. 60,342

MAC:PTM/jnm

Date: December 28, 2009

OLIFF & BERRIDGE, PLC  
P.O. Box 320850  
Alexandria, Virginia 22320-4850  
Telephone: (703) 836-6400

**DEPOSIT ACCOUNT USE  
AUTHORIZATION**

Please grant any extension  
necessary for entry of this filing;  
Charge any fee due to our  
Deposit Account No. 15-0461

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